

Dominique Ortolino defended his doctoral thesis

Congratulations!

Dominique Ortolino defended his doctoral thesis about electrical high load vias in hybrid thick-film technology (German original title "Hochstromdurchkontaktierungen für die Hybridtechnik") on July 29th, 2015.

The research work for his dissertation was conducted in a collaborative project between Conti Temic microelectronic GmbH in Nürnberg and the chair of Prof. Moos. The project was funded by the Bavarian Research Foundation BFS.

Dr. Ortolino already published a part of his thesis in D. Ortolino, J. Kita, R. Wurm, E. Blum, K. Beart, R. Moos, Investigation of the short-time high -current behavior of vias manufactured in hybrid thick-film technology, *Microelectronics Reliability*, **34**, 1257-263 (2011) and D. Ortolino, A. Engelbrecht, H. Lauterbach, M. Bräu, J. Kita, R. Moos, Effect of Repeated Firing on the Resistance of Screen-Printed Thick Film Conductors, *Journal of Ceramic Science and Technology*, **5**, 317- 326 (2014).



Picture from left to right: Prof. Rieg, Prof. Moos, Dr. Ortolino, Prof. Müller (TU Ilmenau), Prof. Brüggemann.